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Article

Implementation of Signal Acquisition System (SAS) for Large Voltage Waveform Using Low-cost Raspberry Pi Pico

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Abstract: In response to Industry 4.0, smart manufacturing with highly developed performances has become an interest of research topic being intensively discussed. To achieve smart manufacturing, it is required to develop an intelligent factory having smart machines. Therefore, advanced low-cost sensing technologies are essential for gathering data and utilizing it for effectively building a smart machine. Recently, various high performance microcontrollers capable of performing data acquisition have been developed for the application of internet of things (IoT). However, the data acquisitions of those microcontrollers are limited to several volts only. Therefore, voltage attenuation is required, thus resulting in the problem of reducing the resolution of acquired signal. In this paper, a signal acquisition system (SAS) using the Raspberry Pi Pico (Pico) that can acquire a large voltage waveform is proposed. Based on the operation of amplitude division, a complete waveform can be reconstructed via the proposed SAS without reducing the resolution. The SAS consists of three components: a signal acquisition circuit dividing a large voltage waveform into several segmented waveforms, a Pico reconstructing the piecewise segmented waveforms, and a laptop recording and displaying the acquired waveform. Through simulation works and practical experiments, it has been demonstrated that a sinusoidal waveform with the amplitude of 10 V and driving frequency of 100 Hz could be well reconstructed. Compared with the method using an attenuated waveform, the amplitude division featured much smaller acquisition error. Future works are to reduce the error of the acquired waveform by compensating for the nonlinearity of the circuit and to implement a real-time acquisition system.

Keywords: Industry 4.0; signal acquisition device; Raspberry Pi Pico; amplitude division; IoT; smart machine

1. Introduction

Industry 4.0 (I4.0) has become an interest of research topic being intensively discussed. It is expected that I4.0 would bring about an extreme impact on manufacturing industry [1, 2]. For guiding the development of I4.0, the performance evaluation architecture has been divided into 5C levels, i.e., 'Connection Level', 'Conversion Level', 'Cyber Level', 'Cognition Level', and 'Configuration Level' [3]. I4.0-based smart manufacturing with highly developed performances can accurately predict product requirements and quickly identify errors, thus improving manufacturing processes and ultimately innovating products and services [4]. However, one of the most important factors to achieve smart manufacturing is to develop an intelligent factory having various smart machines. Therefore, advanced low-cost sensor technologies are essential for gathering data and utilizing it for effectively building a smart machine [5]. With the physical data acquired from sensors, smart manufacturing through machine learning, big data analysis, internet of things (IoT), and digital twin can be developed [6], in addition, the total manufacturing quality system based on decision support

by combining sensor network data and historical data can be designed and realized [7, 8]. Therefore, the smart machine requires the most fundamental components of sensors to acquire manufacturing information such that an intelligent decision can be made based on big data analysis.

Recently, various versions of low-cost microcontrollers capable of performing data acquisition have been developed for the application of IoT, e.g., Arduino UNO and Micro [9], ESP32 and ESP8266 [10], and Raspberry Pi [11], etc. Among those microcontrollers, since the Raspberry Pi features further internet function, it has been widely used in numerous applications, e.g., development of a portable endoscopic 3-dimensional measurement system [12], implementation of data acquisition systems for powered vehicles [13, 14], parametric operations and monitoring of electrical parameters in photovoltaic power plants [15, 16, 17, 18], fault diagnosis and tool monitoring in manufacturing [19, 20, 21, 22, 23, 24, 25], construction of a predictive maintenance mechanism with the test platform and data analysis [26], temperature monitoring and thermal compensations in electrical components and machine tools [27, 28, 29, 30], development of electrical tomography system [31], implement of cloud platform for real-time data acquisition for a legacy machine [32], and development of monitoring systems with the integration of Raspberry Pi cluster and environmental sensor [33], etc. In 2021, a new version of Raspberry Pi Pico (for simplicity, Pico is used afterwards) was developed with additional inputs of analog-to-digital converters (ADCs) [34]. Regarding the performance, the clock speed of Pico behaves faster compared with that of Arduino UNO [35].

However, although those microcontrollers feature low-cost and powerful performances, the analog signal acquisitions via either an embedded or external ADC are limited to several volts only. Therefore, voltage attenuation using operational amplifiers (OPAs) [36] or voltage divider is required [37, 38]. Unfortunately, the voltage attenuation would result in the problem of reducing the small signal component to a level that is outside the resolution of the ADC [39]. In this paper, a signal acquisition system (SAS) using the Pico that can acquire a large voltage of 10 V with both positive and negative polarities is proposed. Based on the operation of amplitude division, a complete voltage waveform can be reconstructed in the microcontroller, thus without losing small signal due to attenuation. In preliminary study, the function of the SAS was verified [40]; in this paper, detailed electronic composition, simulation works, and performance comparison with that using the voltage attenuation are presented.

In the next section, acquisition principle of the SAS is described. Then, detail implementation of the SAS is presented in section 3. This is followed by the simulation works and experimental verification provided in sections 4 and 5, respectively. Finally, a conclusion is given in section 6.

2. Acquisition Principle

Figure 1 shows the acquisition principle of the proposed SAS for a sinusoidal signal with a large amplitude. In the beginning, the input alternating current (AC) voltage waveform is rectified into the one having the positive polarity only. Then, a voltage divider is used to provide several reference voltages, i.e., the multiples of 3.3 V. In the next, the rectified voltage waveform is compared to the reference voltages for division. As a result, several segmented waveforms having the maximum amplitude of 3.3 V are obtained via subtracting the rectified waveform with the reference voltages. Therefore, the segmented waveforms can be precisely and fully sensed by the Pico. Finally, a program is implemented to reconstruct the large voltage waveform via arithmetic operation.

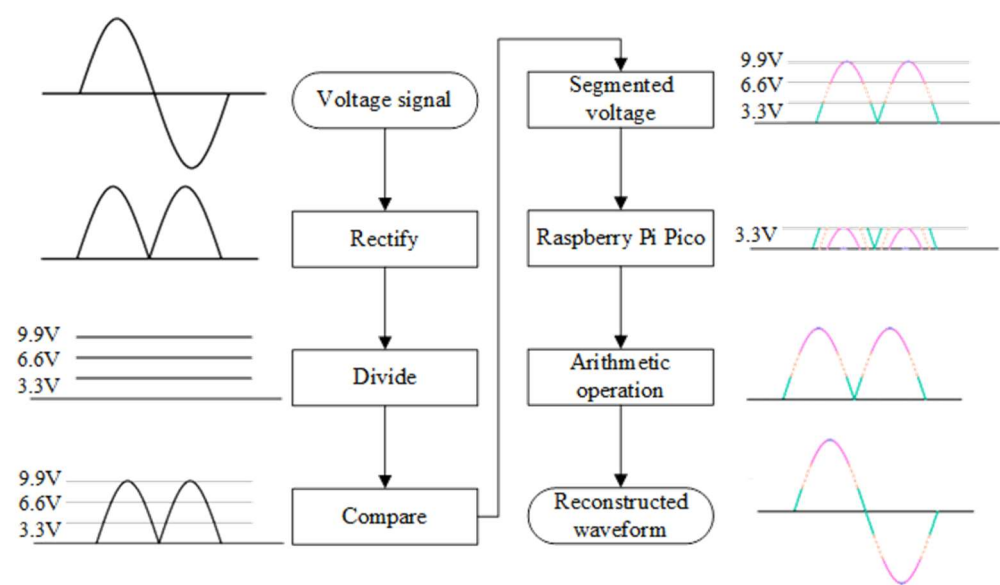


Figure 1. Acquisition principle of the SAS.

3. Implementation of Signal Acquisition System

According to the acquisition principle shown in Figure 1, the SAS using Pico is configured as shown in Figure 2, in which three main components are depicted, including a signal acquisition circuit, Pico, and a laptop. Detailed composition is described in this section.

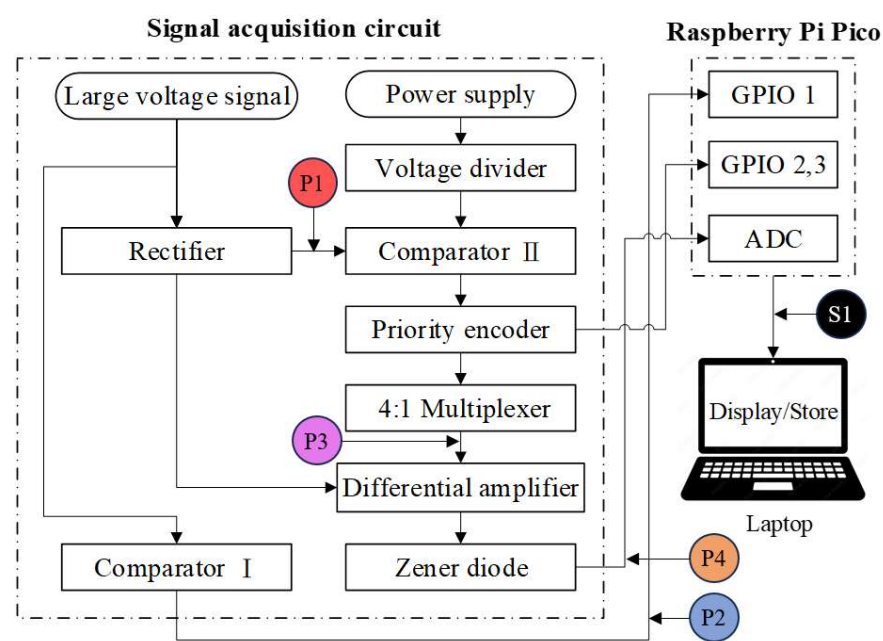


Figure 2. Main components of the SAS.

3.1. Signal Acquisition Circuit

The main function of signal acquisition circuit is to divide the input large voltage waveform into several segmented waveforms that can be completely sensed by the Pico. As shown in Figure 2, various electronic elements are employed, including a power supply, precision rectifier, voltage divider, priority encoder, 4:1 multiplexer (MUX), differential amplifier, zener diode, and two comparators. Their functions are briefly described in the following sections.

3.1.1. Precision Rectifier

Figure 3 shows the constitution of the precision rectifier comprising two OPAs, two zener diodes, and three resistors [41]. The precision rectifier can precisely rectify the AC waveform into a positive voltage waveform. To keep a complete waveform, it is unnecessary to the eliminate the ripple voltage.

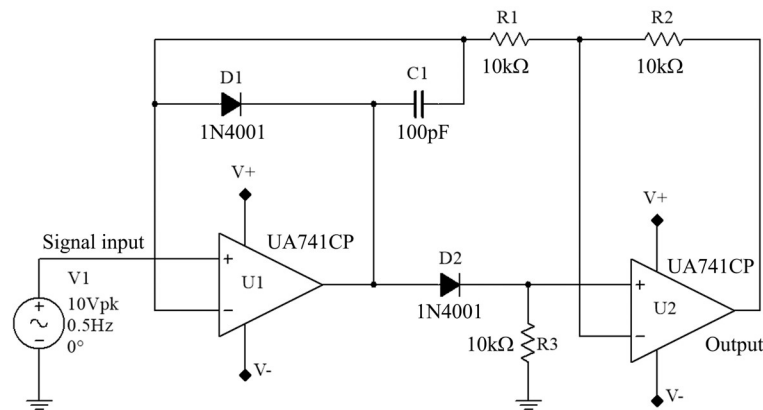


Figure 3. The constitution of a precision rectifier.

3.1.2. Voltage Divider

The voltage divider is consisted of four series connected $330\ \Omega$ resistors. With the direct current (DC) power supply V_{DC1} of 13 V, four reference voltages of 0, 3.3 V, 6.6 V, and 9.9 V are provided as shown in Figure 4.

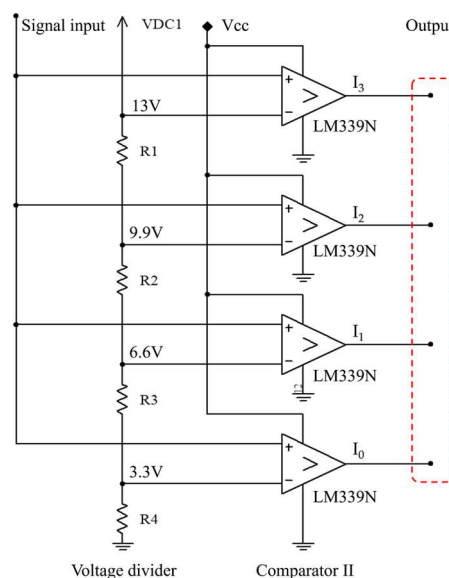


Figure 4. The voltage divider with four reference voltages for comparator II.

3.1.3. Comparators

Two comparators made of OPAs are used in the circuit. As shown in Figure 2, the comparator I is to examine either positive or negative polarity of the voltage waveform. Then, the polarity information is sensed by the Pico via the No.1 general purpose input/output (GPIO 1) as a digital port. On the other hand, the comparator II are made of three OPAs such that the amplitude comparisons among three cases of larger than 3.3 V, 6.6 V, and 9.9 V can be conducted as shown in Figure 4, in which the first OPA is to produce a LOW signal for the priority encoder. Therefore,

including the case of $\leq 3.3\text{ V}$, four ranges of segmented waveforms can be identified, i.e., $\leq 3.3\text{ V}$, $3.3 - 6.6\text{ V}$, $6.6 - 9.9\text{ V}$, and $> 9.9\text{ V}$. The output digital signals noted with I_j ($j = 0$ to 3) are sent to the priority encoder for recording four voltage ranges.

3.1.4. Priority Encoder

Having identified four segmented waveforms via the compotator II, a 4:2 priority encoder is used to receive the information, and output 2-bit digital signals with 2^2 combinations, as shown in Figure 5, for the GPIO 2 & 3 to retrieve. Compared with the usual encoder that allows only one High level input, the priority encoder has a unique function to deal with some inputs having the same High level signal. That is because of the comparator II would produce multiple High signals when the voltage amplitude is larger than 3.3 V . The True table of the priority encoder is shown in Figure 5, in which X denotes “don’t care”.

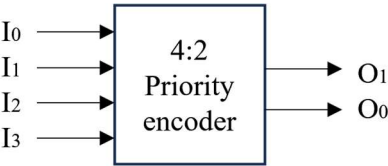


Figure 5. Input/output ports of a 4:2 priority encoder.

Table 1. True table of a 4:2 priority encoder.

Input				Output	
I ₃	I ₂	I ₁	I ₀	O ₁	O ₀
X	X	X	0	0	0
X	X	0	1	0	1
X	0	1	1	1	0
0	1	1	1	1	1

3.1.5. Multiplexor and Differential Amplifier

After assigning the information of four segmented waveforms to the encoder, the 4:1 multiplexor is used to select one of the reference voltages v_{ref} , i.e., $0, 3.3\text{ V}, 6.6\text{ V}$, and 9.9 V for the differential amplitude to subtract. Therefore, an input large voltage waveform v_{in} can be divided into four segmented waveforms with the maximum amplitude of 3.3 V that can be sensed by the Pico. A zener diode is used to limit the input voltage being under 3.3 V for protecting the Pico. The constitution of the differential amplitude is shown in Figure 6. The output segmented waveforms v_{out} obtained with the amplitude division are expressed as follows,

$$v_{out} = \frac{R_2}{R_1} (v_{in} - v_{ref})$$

(1)

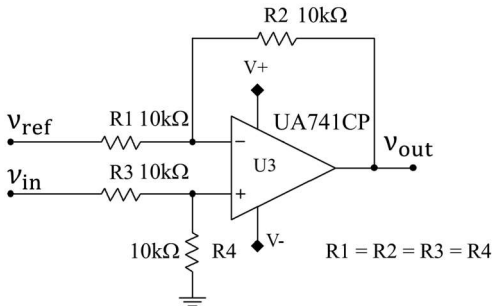


Figure 6. Differential amplifier for providing the segmented waveform.

3.2. Raspberry Pi Pico

Pico is a microcomputer chip equipped with various components such as digital input and output (I/O) ports, memory, and networking element, etc. It has been widely employed in automation

machinery. With the analog input function of ADCs, the main specifications of Pico are listed in Table 2.

Table 2. Main specifications of Pico.

Microcontroller		Clock speed(MHz)	SRAM (Kbyte)	Flash memory (Byte)	ADC(bit)	ADC voltage range (V)
Pico	RP2040	133	264	2M	12	0~3.3

3.2.1. GPIO

As shown in Figure 2, the GPIO 1 is used to record the polarity of waveform, whereas the GPIO 2 & 3 are used to store the reference voltages of segmented waveforms. The True table of the GPIO ports are expressed in Table 2.

Table 2. True tables of the GPIO 1 ~ 3 ports.

GPIO		GPIO		v_{ref} (V)
1	Polarity	2	3	
0	Positive	0	0	0
1	Negative	0	1	3.3
		1	0	6.6
		1	1	9.9

3.2.2. ADC

The segmented waveforms having the maximum amplitude of 3.3 V are acquired via the ADC port. Since the resolution of ADC of Pico is 12-bit, the acquired voltage signal is with the resolution of 0.81 mV ($= 3.3/2^{12}$ V). However, because the program is implemented by the MicroPython which defines the resolution of ADC be 16-bit, the acquired segmented waveform v_s is expressed as follows,

$$v_s = v_{out} * (\frac{3.3}{2^{16}})$$

(2)

where v_{out} is the sensed segmented waveform of ADC.

3.2.2. Waveform Reconstruction Program

Having obtained the information of polarity, reference voltage v_{ref} , and sensed segmented waveform v_s , a complete waveform is reconstructed via the implemented program with the flowchart shown in Figure 7. In the beginning, the reference voltage v_{ref} is selected based on the GPIO signals, then the value of v_{ref} is added to the segmented waveform, as a result, the complete waveform can be obtained and stored into a text file. Finally, a full voltage waveform can be displayed on the laptop via graphical package.

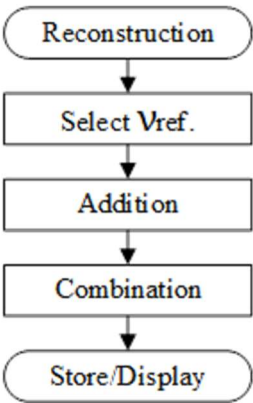


Figure 7. Flowchart of waveform reconstruction program.

The algorithm of selecting the reference voltage is shown in Figure 8. Firstly, the positive polarity is checked based on the GPIO 1 signal, then the reference voltage larger than 3.3 V, 6.6 V, or 9.9 V is sequentially examined according to the signals of GPIO 2&3. As a result of the examinations, one of the positive reference voltages, i.e., 0, 3.3 V, 6.6 V, and 9.9 V, can be determined. On the other hand, when the negative polarity is checked, similar to previous processes, one of the negative reference voltages can be determined. From the flowchart, it is noted that the larger the reference voltage is, the longer is the examining process. In addition, the positive polarity has a shorter examining process compared to the negative one for the same value. **Error! Reference source not found.**9 shows the screen copies of program executions for (a) an acquisition example of ADC, indicating the acquired readings of v_{out} ranging 0 ~ 65535 due to the MicroPython resolution of 16-bit, and (b) part of waveform reconstruction program based on flowchart of Figure 7.

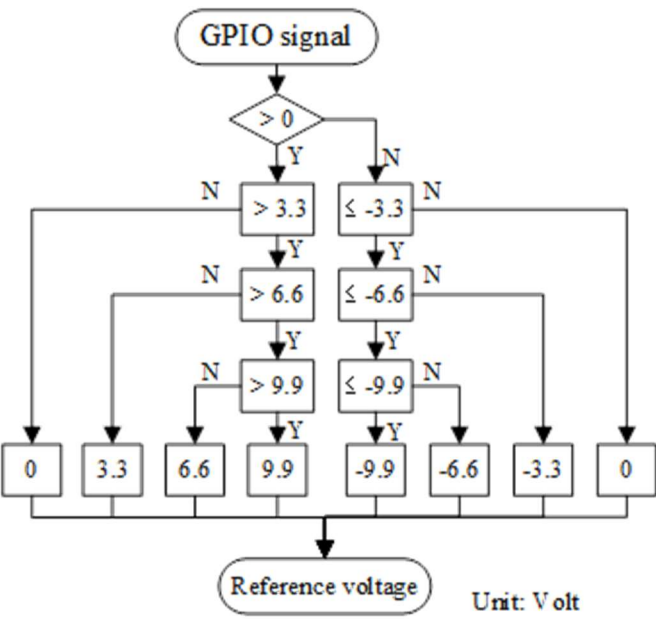


Figure 8. Flowchart of selecting the reference voltage.

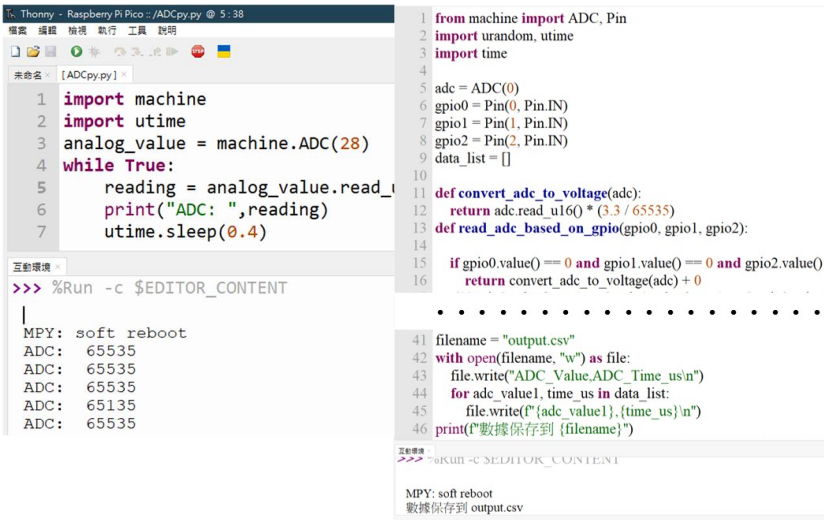


Figure 9. Screen copies of program executions.

4. Simulation Works

According to the configuration shown in Figure 2, the simulation works were performed using the simulation program with integrated circuit emphasis (SPICE) package. The acquired data include a complete waveform, segmented waveforms, reference voltages, and polarity signal.

4.1. Simulation Waveforms and Signals

Figure 10 shows the simulation results for a sinusoidal waveform with an amplitude of 10 V and a frequency of 0.5 Hz. The numerical probes were placed on the outputs of rectifier P1, comparator I P2, MUX P3, and zener diode P4, as shown in Figure 2. Firstly, the rectifier flipped the negative voltage waveform into the positive one, and the comparator I provided the step signal showing the positive and negative polarities. Then the MUX selected the reference voltages expressed by stepwise signals, and the differential amplifiers outputted the piecewise segmented waveforms with the maximum amplitude of 3.3 V kept by the zener diode. Finally, the full waveform S1 having both the positive and negative polarities was completely reconstructed via the algorithm presented in Figure 7.

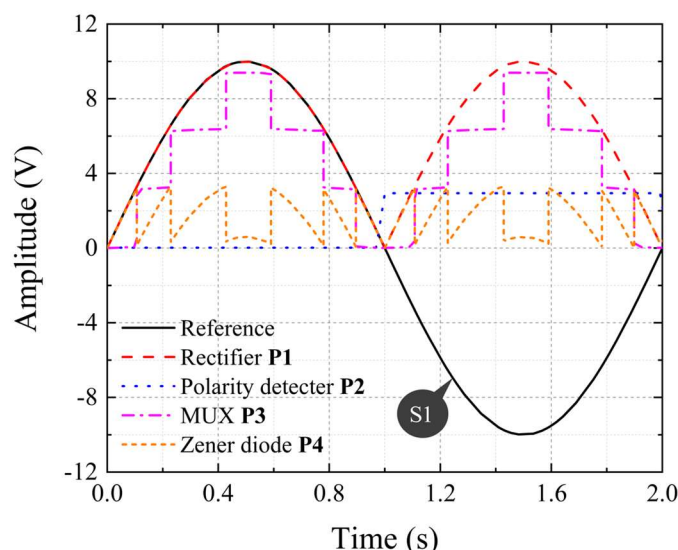


Figure 10. Simulation results of reconstructed waveform and signals.

4.2. Simulation Waveform Affected by Frequency

By applying two different frequencies of 1 Hz and 100 Hz to the simulation circuit, the reconstructed waveforms and calculated errors are shown in Figure 11. From the results, although two waveforms could be smoothly reconstructed, errors with various spikes were found. Notably, large spike peaks of -0.2 V and 0.1 V appeared at the crossovers of polarity change for 1 Hz and 100 Hz, respectively. Figure 12 shows the peak-to-valley (PV) error affected by the actuating frequency. When the driving frequency was under 100 Hz, the PV error was with the similar value of 0.25 V, however, it significantly rose when the driving frequency was larger than 100 Hz.

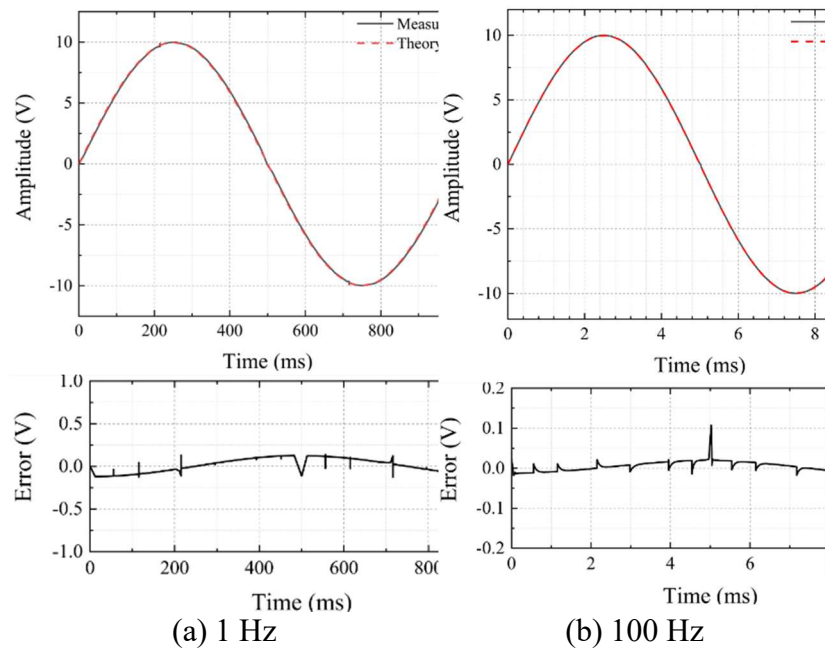


Figure 11. Simulation results of reconstructed waveforms and errors.

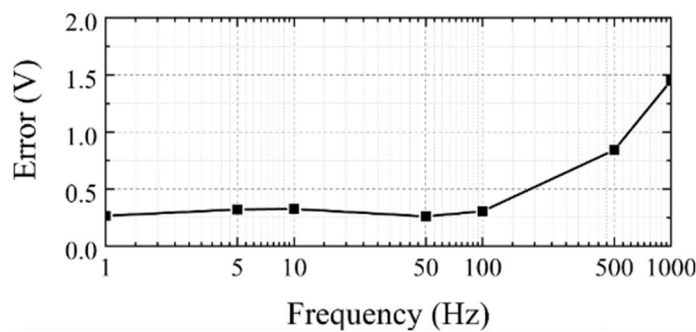


Figure 12. Simulation results of the PV error affected by the frequency of waveform.

5. Experimental Verification

Similar to the simulation works, experimental verification was performed with the implemented SAS. In addition to the same information obtained with the simulation works, acquisition time delay of ADC, and the signal acquisitions based on the SAS are compared with that using the attenuated waveforms based on a voltage divider.

5.1. Experimental setup

Figure 13 shows the experimental setup for examining the proposed SAS. The DC power supply is used to provide constant voltages to the signal acquisition circuit, and a function generator is employed to produce the sinusoidal waveforms with various frequencies. An oscilloscope is provided to record the input waveform, segmented waveforms, reference voltages, and polarity signal. The Pico is used to acquire the segmented waveform, and to reconstruct the full waveform based on the GPIO digital signals. A laptop is employed to record the acquired data and present graphical display. Figure 14 is the photograph of experimental setup.

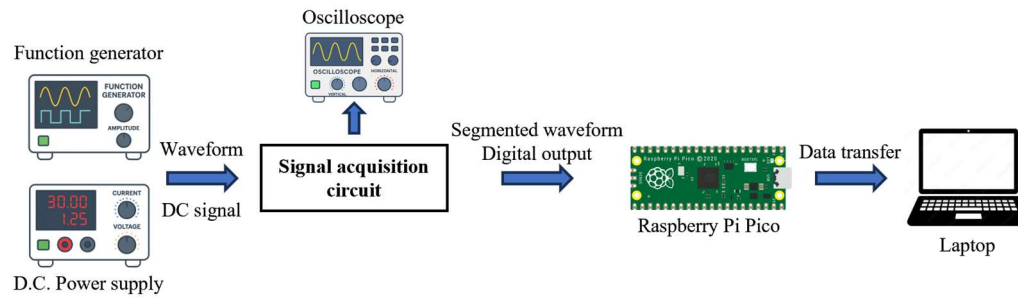


Figure 13. Experimental setup for examining the performances of proposed SAS.

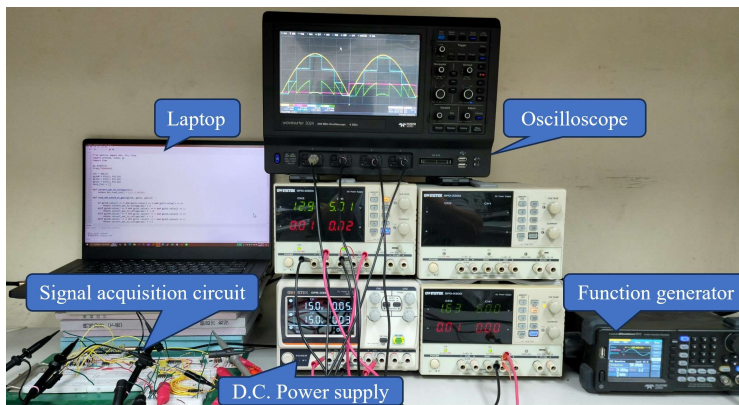


Figure 14. Photograph of experimental setup.

5.2. Measured Time Delay of ADC

To examine the time delay of signal acquisition, DC voltages were applied to the SAS. The time delay is referred to the time interval between the voltage is just sensed by the ADC port and then output a “print” command after computational process. Figure 15 shows the relation between the delay time vs. the amplitude with polarity of the voltage. The voltages were applied by the reference voltages, i.e., 0, 3.3 V, 6.6 V, and 9.9 V but with both positive and negative polarities. Every value was acquired 10 times for examining the repeatability. As shown in the figure, when the voltage is 0, it results in the average time delay of 93.1 μ s; on the other hand, when the voltage is -9.9 V, it appears the largest time delay of 125 μ s. That is, the sampling rate could reach 8,000 samples per second. Also, it is observed that the larger the amplitude is, the longer is the delay time; and the positive polarity behaves a shorter time delay for the same amplitude due to a higher calculation priority. This copes well with the algorithm of determining the reference voltage depicted in Figure 8.

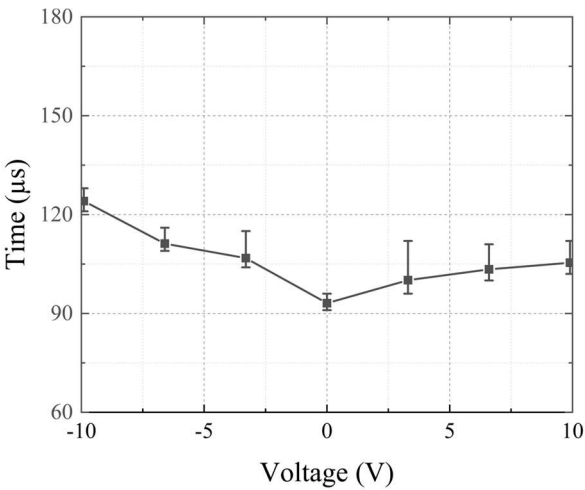


Figure 15. Measured time delay of DC voltage.

5.3. Measured Results of Sinusoidal Waveform

Based on the implemented experimental setup, experiments were conducted. Similar to simulation works, the input waveform with a large amplitude was divided into several segmented waveforms with maximum amplitude of 3.3 V via the signal acquisition circuit, then the segmented waveforms were acquired with the Pico, and a complete waveform was reconstructed by the implemented program. In addition, the measured errors affected by frequency were examined.

5.3.1. Reconstruction Waveform and Measured Signals

Figure 16 shows the reconstructed waveform and measured signals for an input sinusoidal waveform with an amplitude of 10 V and a frequency of 0.5 Hz. The oscilloscope probes were placed on the outputs of rectifier P1, comparator I P2, MUX P3, and zener diode P4, as shown in Figure 2. The complete waveform S1 was reconstructed via the implemented program of Pico. Similar to the simulation results, P1 recorded the positive and rectified waveforms; P2 presented the step signal showing the positive and negative polarities; P3 showed the stepwise reference voltages; and P4 indicated the piecewise segmented waveforms. Finally, S1 demonstrated the reconstructed waveform. Therefore, the effective function of proposed SAS was experimentally demonstrated.

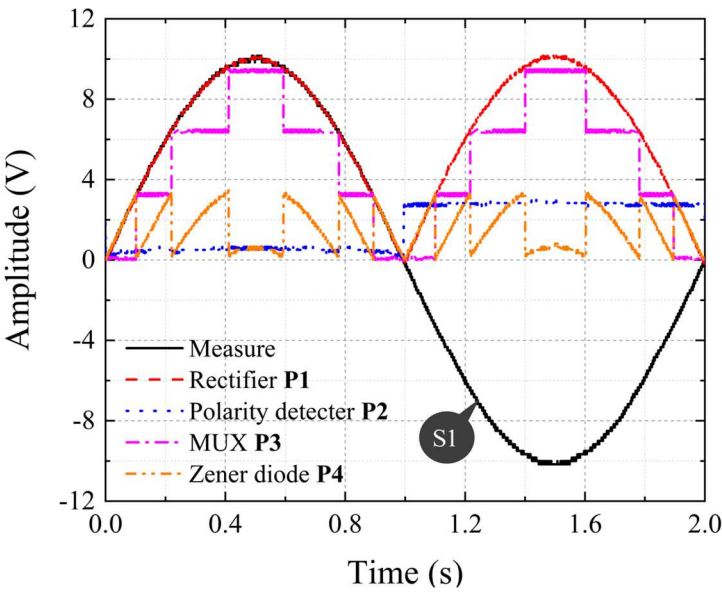


Figure 16. Reconstructed waveform and measured signals based on SAS.

5.3.2. Reconstructed Waveform Affected by Frequency

In addition, by applying two sinusoidal waveforms with the frequencies of 1 Hz and 100 Hz to the signal acquisition circuit, the reconstructed waveforms and calculated errors are shown in Figure 17. From the results, it is shown that two waveforms could be smoothly reconstructed, and the error ranges were ranged in $-0.2 \sim 0.1$ V and $-0.13 \sim 0.13$ V for the frequencies of 1 Hz and 100 Hz, respectively. The PV error with the relation to the frequency is depicted in Figure 18. When the driving frequency was under 100 Hz, the PV error fluctuated within $0.27 \sim 0.34$ V. However, it significantly increased to 0.95 V and 3.6 V when the frequencies were 500 Hz and 1 kHz, respectively.

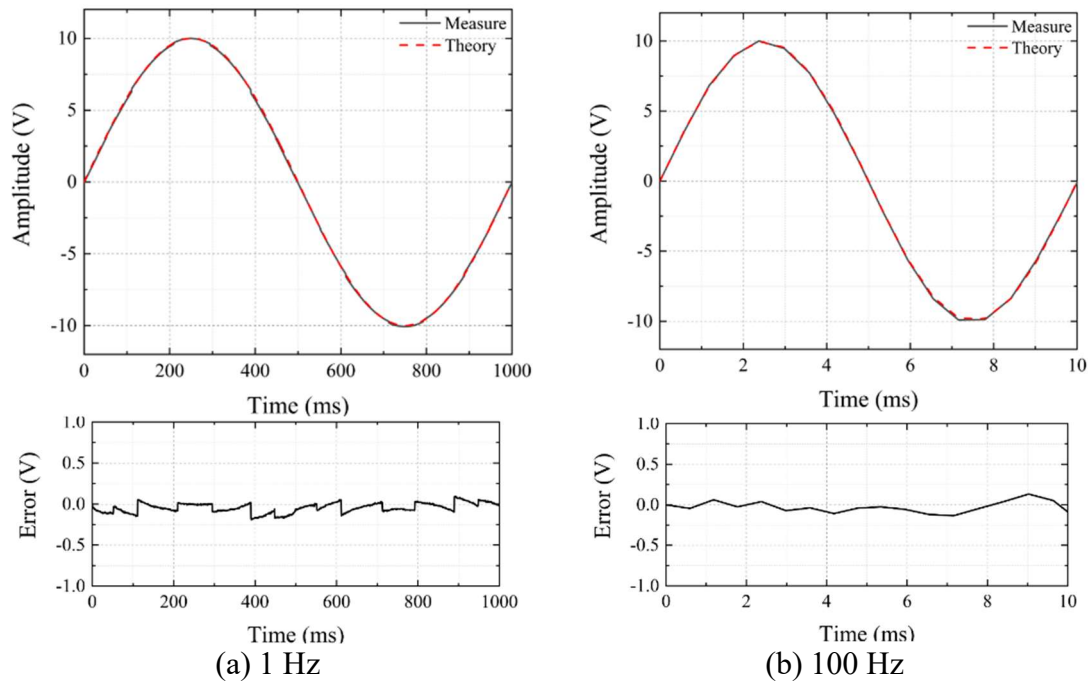


Figure 17. Experimental results of reconstructed waveforms and errors.

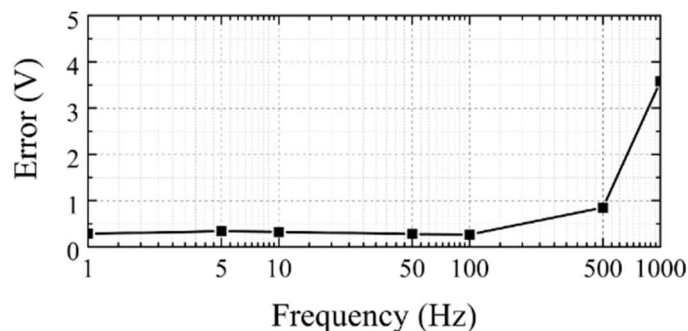


Figure 18. The measured PV error affected by frequency of waveform.

5.4. Measured Results of Attenuated Sinusoidal Waveform

To further demonstrate the effectiveness of the proposed SAS, referring to the voltage attenuation based on voltage divider [37, 38], the sinusoidal waveforms with the amplitude of 10 V were attenuated to 3.3 V with the experimental configuration shown in Figure 19, where v'_{in} is the attenuated waveform. After acquiring the attenuated waveforms using the SAS, their amplitudes were amplified with the ratio of $10/3.3$ for comparison consistency. As a result, the experimental results for the attenuated waveforms are shown in Figure 20. It can be seen that although both the waveforms having the frequencies of 1 Hz and 100 Hz could be smoothly reconstructed, their corresponding errors were with the similar range of $-0.5 \sim 0.4$ V, which were

much worse than previous results without voltage attenuation. In addition, the PV error affected by the frequency is shown in Figure 21, when the driving frequency was under 100 Hz, the PV error nearly reached 1 V. When the frequency was 500 Hz, the PV error increased to 3 V. As a result of the examinations, the proposed SAS that features better accuracy compared to that using the voltage divider was demonstrated.

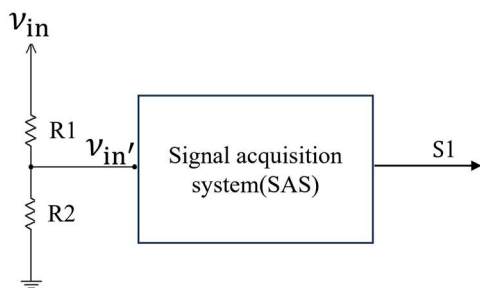


Figure 19. The experimental setup for examining the attenuated waveform based on voltage divider.

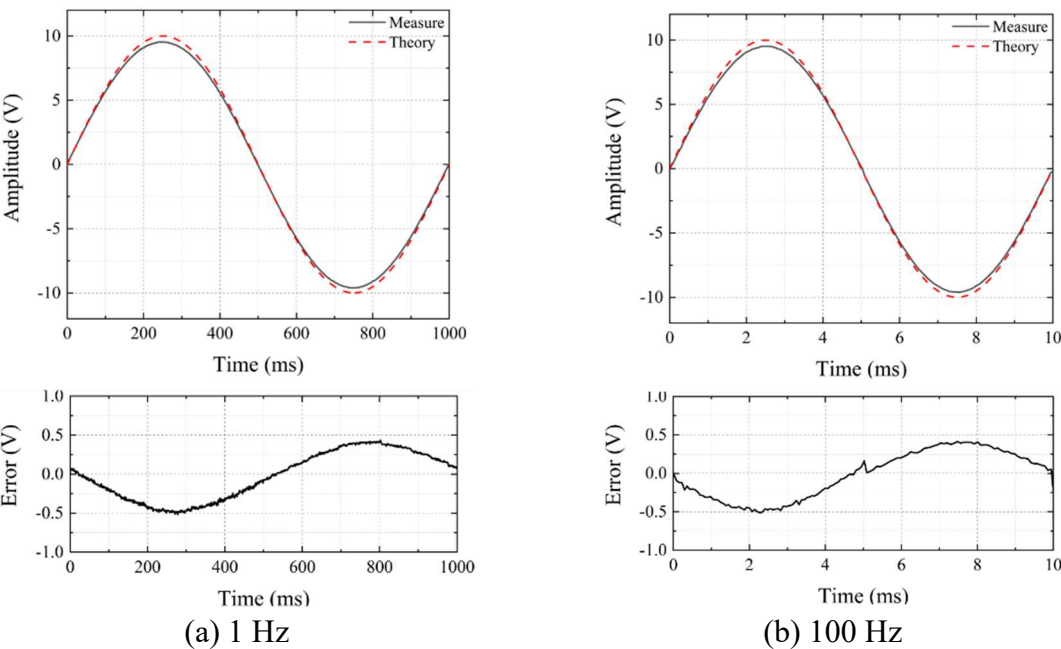


Figure 20. Reconstructed waveforms and errors of the attenuated waveform.

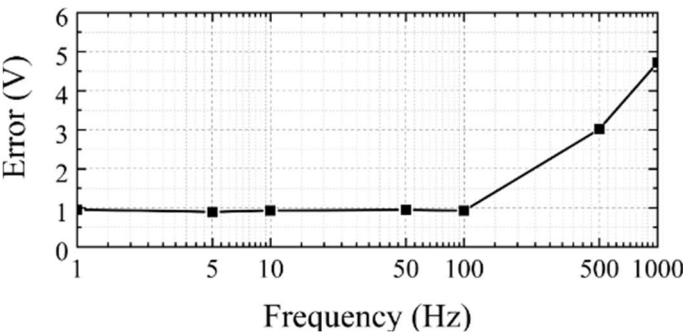


Figure 21. The PV error affected by frequency of attenuated waveform.

6. Conclusions

To overcome the weakness of acquisition ability of small voltage of a microcontroller, a signal acquisition system capable of acquiring a large voltage waveform based on low-cost Raspberry Pi Pico was proposed. The SAS was employed to divide the waveform having a large amplitude into several segmented waveforms that can be sensed by the Pico, and the full waveform was reconstructed via implemented program. Through simulation works and experimental examinations, the effectiveness of the SAS was demonstrated. Main results are drawn as follows,

- (1) The simulation results based on SPICE showed that a sinusoidal waveform with a large amplitude could be sensed and smoothly reconstructed. When the frequency was under 100 Hz, the PV error was with the value of 0.25 V.
- (2) The DC voltages were applied to examine the time delay of voltage acquisition. When the voltage was 0, the average time delay was 93.1 μ s; when the voltage was -9.9 V, the SAS appeared the largest time delay of 125 μ s. That is, the sampling rate could reach 8,000 samples per second.
- (3) The experimental results based on SAS showed that a sinusoidal waveform with a large amplitude could be sensed and smoothly reconstructed. When the frequency was under 100 Hz, the PV error fluctuated within 0.27 ~ 0.34 V.
- (4) The experiments for the attenuated waveform based on the voltage divider were conducted. Although the waveforms could be smoothly reconstructed, the PV error ranging -0.5 ~ 0.4 V showed much worse acquisition accuracy than that without voltage attenuation.

Future works are to improve the acquisition accuracy by compensating for the nonlinearity of the acquisition circuit and implementing a device with on-line acquisition function.

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Conflicts of Interest: The authors declare no conflicts of interest.

Abbreviations

The following abbreviations are used in this manuscript:

AC	Alternating current
ADC	Analog-to-digital converter
DC	Direct current
GPIO	General purpose input/output
I4.0	Industry 4.0
IoT	Internet of things
MUX	Multiplexor
OPA	Operational amplifier
SAS	Signal acquisition system
SPICE	Simulation program with integrated circuit emphasis

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